

An Overview of Current and Emerging Water Treatment Technologies

Presented by :

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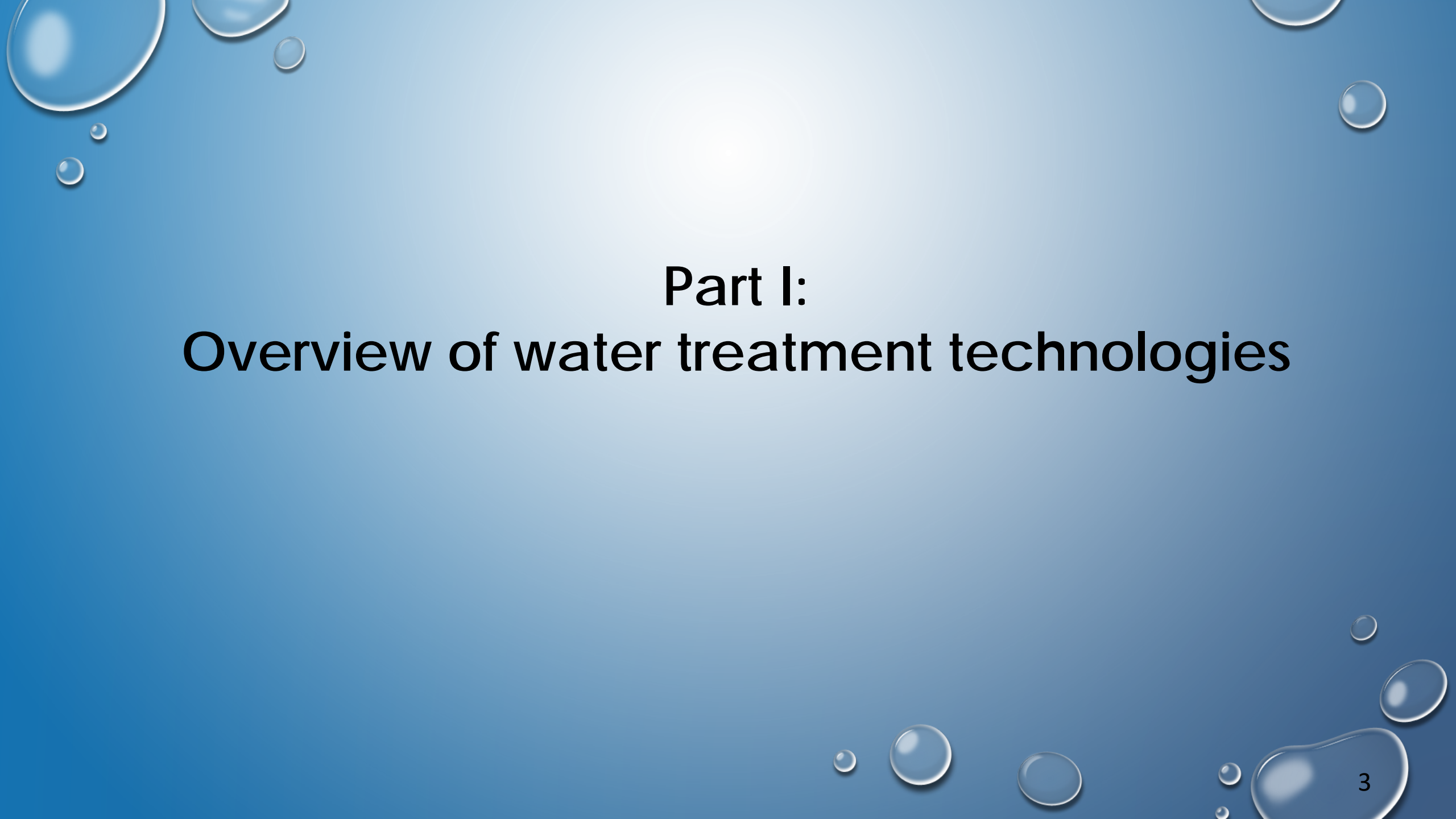
Presentation Layout

Part I: Overview of water treatment technologies

Part II: Characteristic of drain rinsing water

Part III: Semiconductor wastewater treatment technologies

Part IV: Some ideas for treatment technologies

The background is a blue gradient with several realistic water droplets of various sizes scattered across the surface. The droplets have highlights and shadows, giving them a three-dimensional appearance.

Part I: Overview of water treatment technologies

Overview of Water Treatment Technologies

Traditional Thermal processes

- Multi-Effect Distillation (MED)
- MED with vapour compression
- Multi-stage flash evaporation (MSF)

Membrane processes

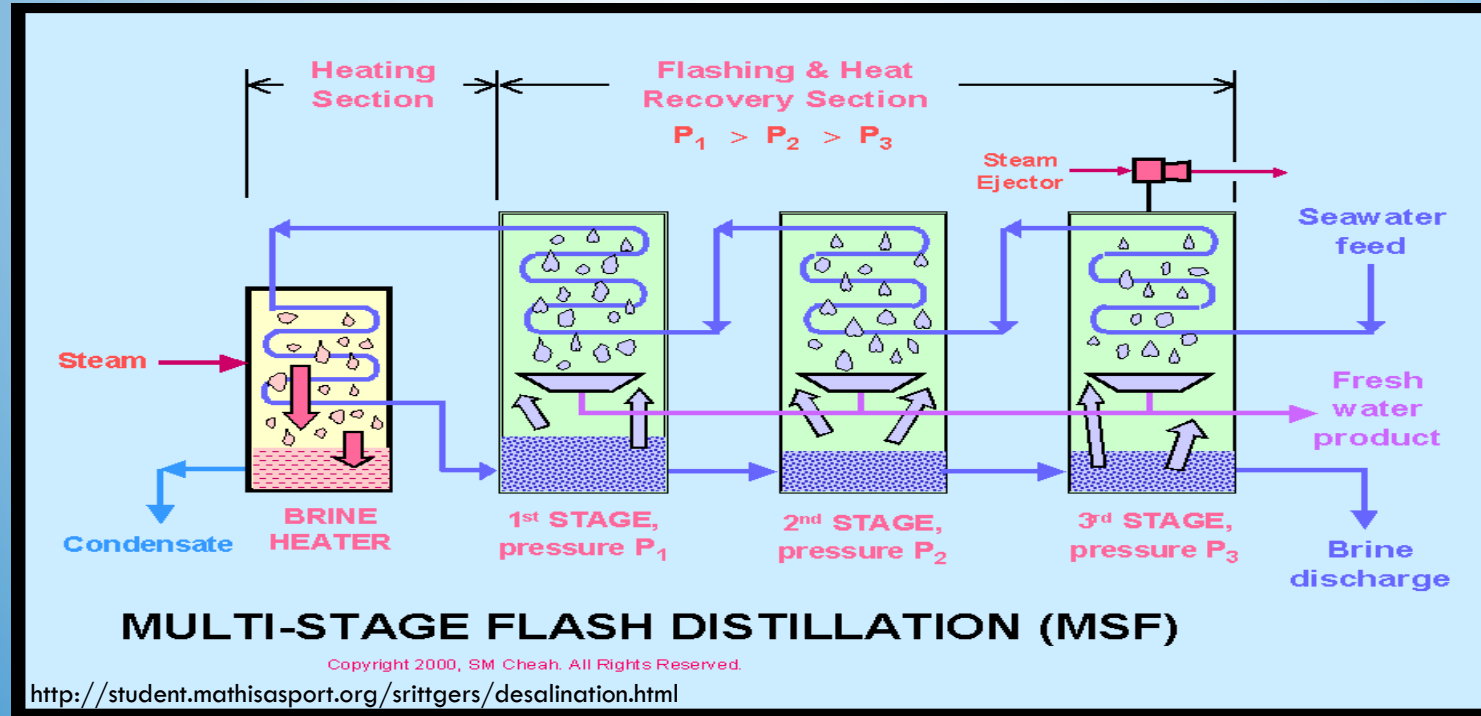
- Reverse Osmosis (RO)
- Electrodialysis (ED)
- Electrodeionization (EDI)
- Membrane Distillation (MD)

Non-traditional processes

- Humidification Dehumidification (HDH)
- Forward Osmosis (FO)
- Freezing-Melting (FM)
- Ion Exchange (IX)

Traditional Thermal processes

Multi-stage flash (MSF):



Advantages

- No pre-treatment
- Less fouling and scaling problem compared with Multi-Effect Distillation (MED)

Disadvantages

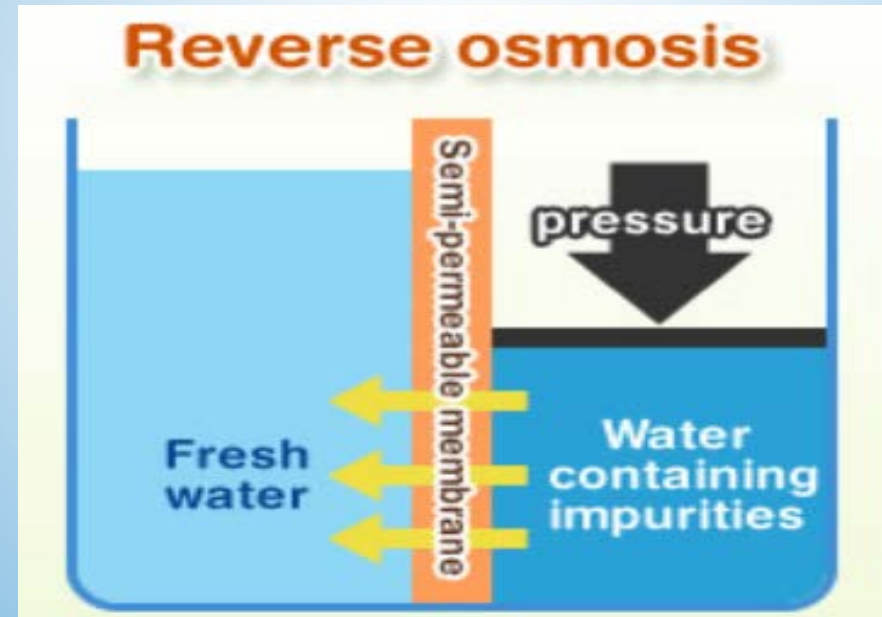
- Thermodynamic efficiency is lower than MED
- Almost 70% of the input heat is lost during the process
- High energy consumption

Current status/research focus

- Improvements in thermodynamics

Membrane processes

Reverse Osmosis (RO):

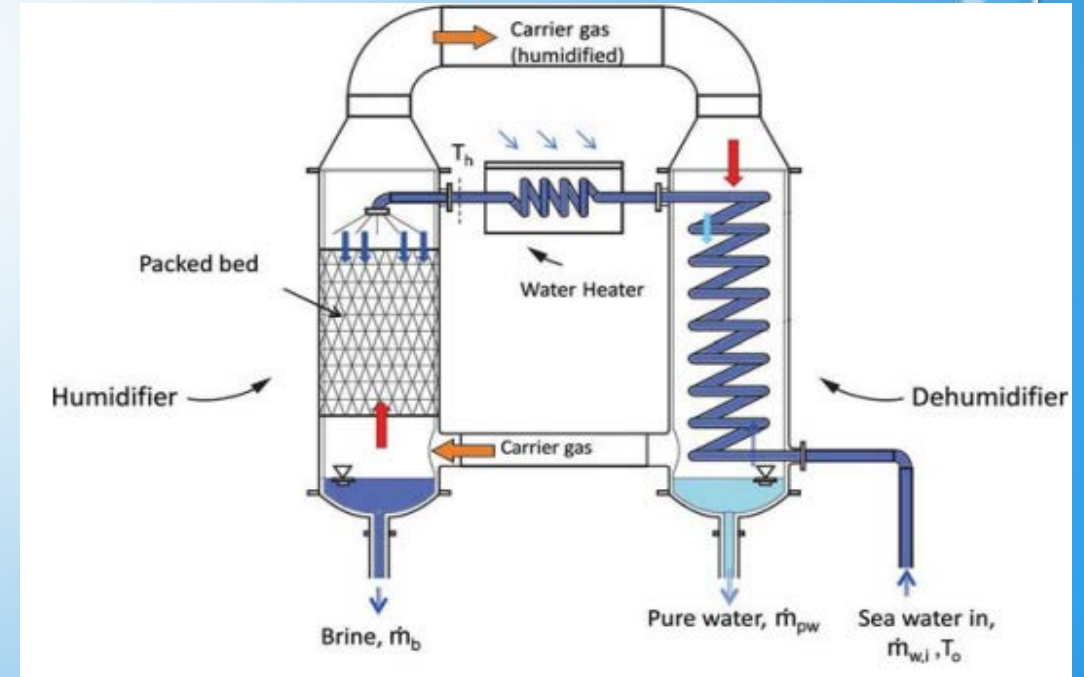
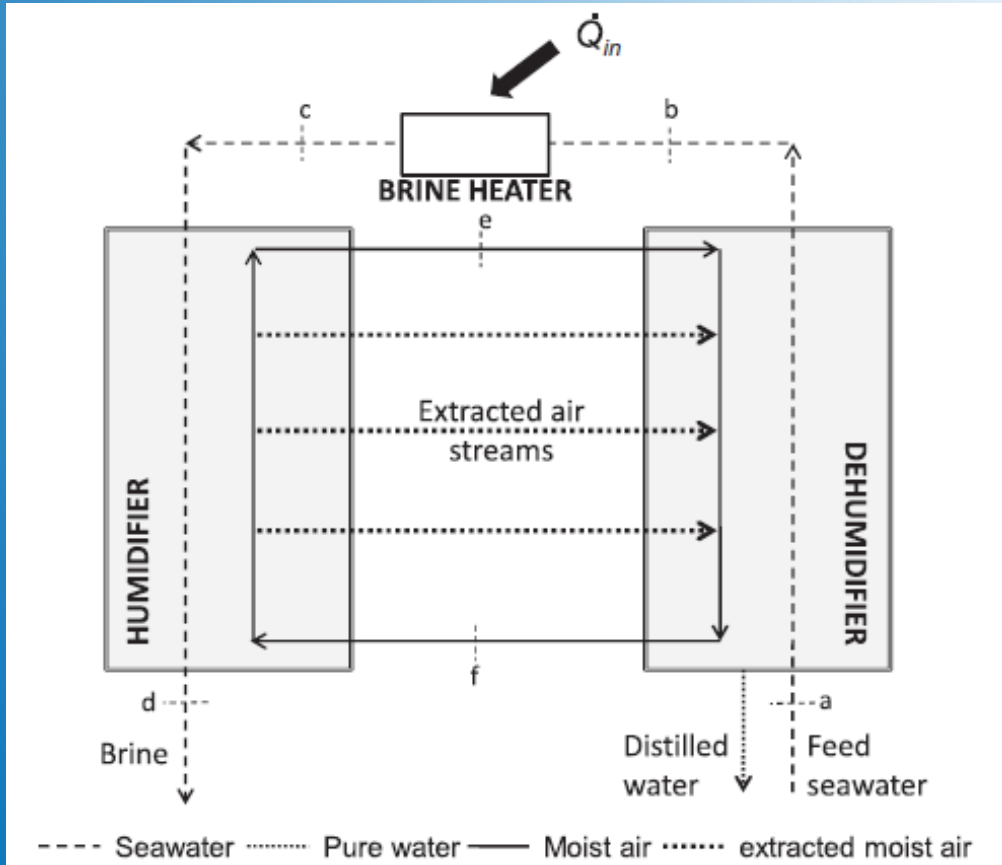


Advantages	Disadvantages	Current status/research focus
<ul style="list-style-type: none">• Low energy consumption (no liquid phase change) compared with Multi-Effect Distillation (MED)• Pumping energy can be recovered• Able to separate many types of contaminants	<ul style="list-style-type: none">• High maintenance and cleaning• Low permeate flux due to membrane fouling• Need for high grade energy source (electricity)• Pre-treatment requirement	<ul style="list-style-type: none">• Fouling resistance as well as reduction in energy while maintaining or improving rejection

Non-traditional processes

Thermal processes

Humidification Dehumidification (HDH):

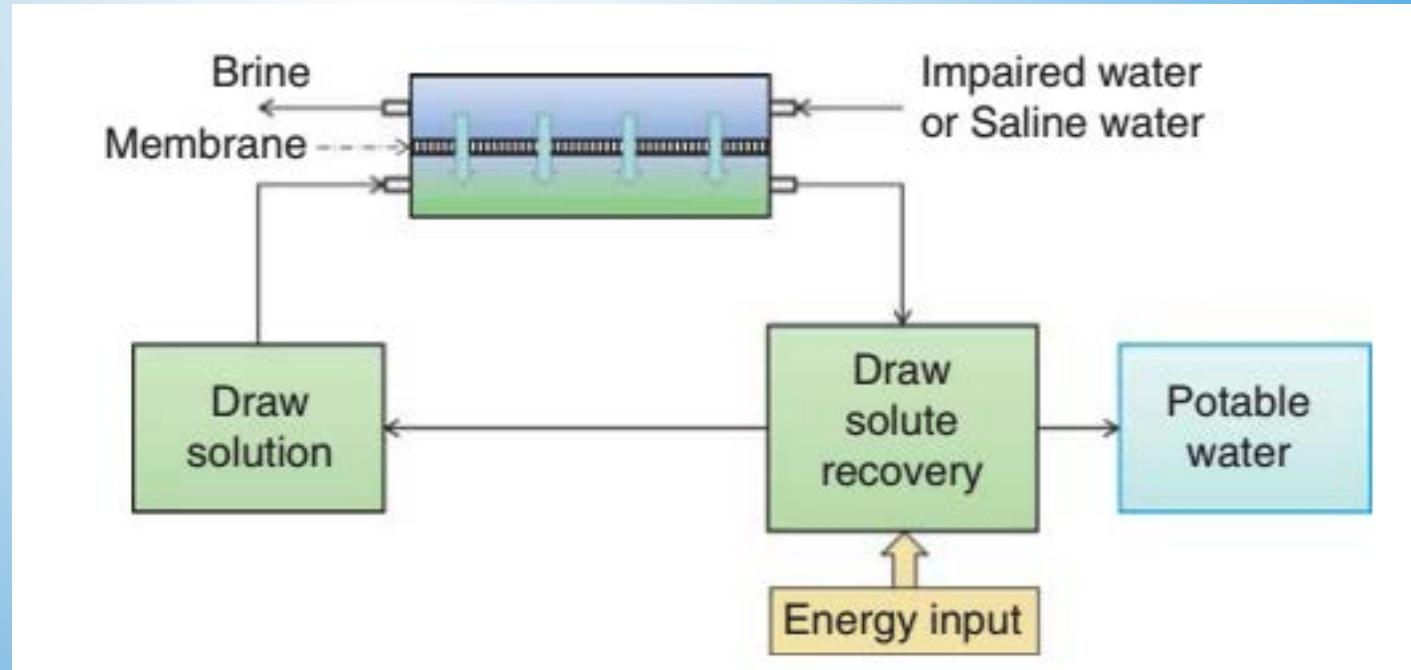


Advantages	Disadvantages	Current status/ research focus
<ul style="list-style-type: none"> • Able to use waste heat sources • Atmospheric pressure • Easily scale up 	<ul style="list-style-type: none"> • Energy consumption 	<ul style="list-style-type: none"> • Recent improvements have made it an economic solution • <i>Now is commercialized in fracking sites (company: Gradient)</i>

Non-traditional processes

Membrane processes

Forward Osmosis (FO):



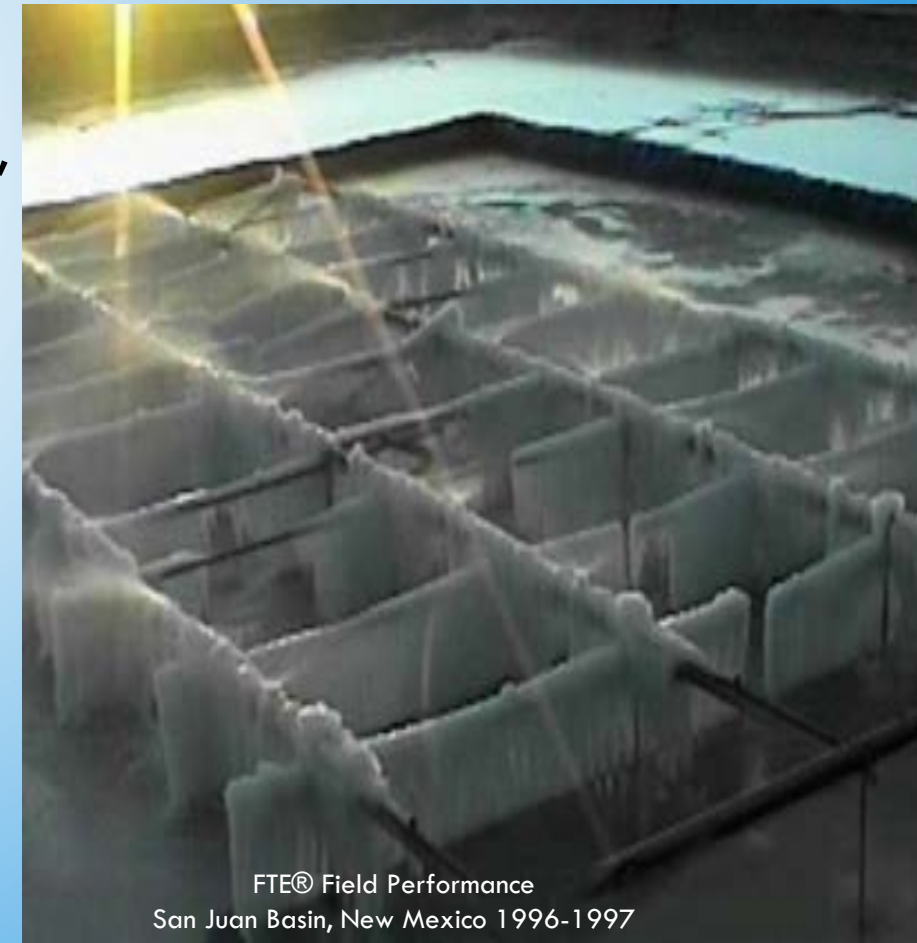
Advantages	Disadvantages	Current status/ research focus
<ul style="list-style-type: none">• No external pressure is required• Highly fouling resistant and easily cleanable• Energy consumption is similar to RO• No need for high grade energy source	<ul style="list-style-type: none">• Thermal energy is necessary to regenerate the draw	<ul style="list-style-type: none">• Gaining commercial application for desalination, particularly since 2010

Non-traditional processes

Freezing-Melting (FM):

- Relatively pure ice crystals form, and an unfrozen solution (brine), containing elevated concentrations of the dissolved constituents, drains from the ice.

Advantages	Disadvantage	Current status/ research focus
<ul style="list-style-type: none">• Main advantage is low energy requirement (fusion energy 1/7 of evaporation energy)• Less scaling and fouling problem• No need for pre-treatment• 90% removal efficiency for:<ul style="list-style-type: none">✓ Total suspended solids (TSS)✓ Total dissolved solids (TDS)✓ Volatile organic compounds✓ Heavy metals	Ice separation	<ul style="list-style-type: none">• Under Development• Currently limited to food processing



Non-traditional processes

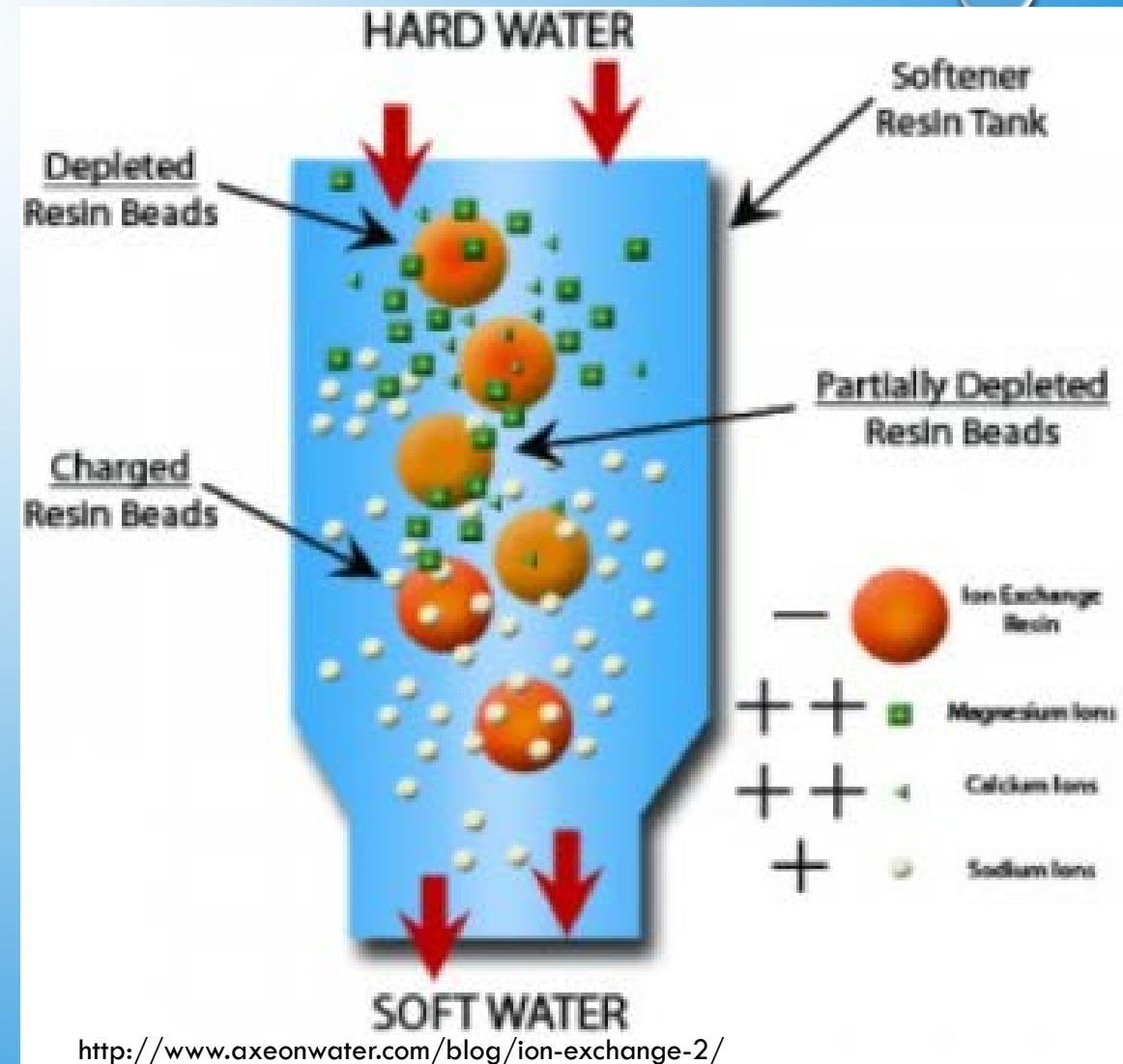
Ion Exchange (IX):

Advantages

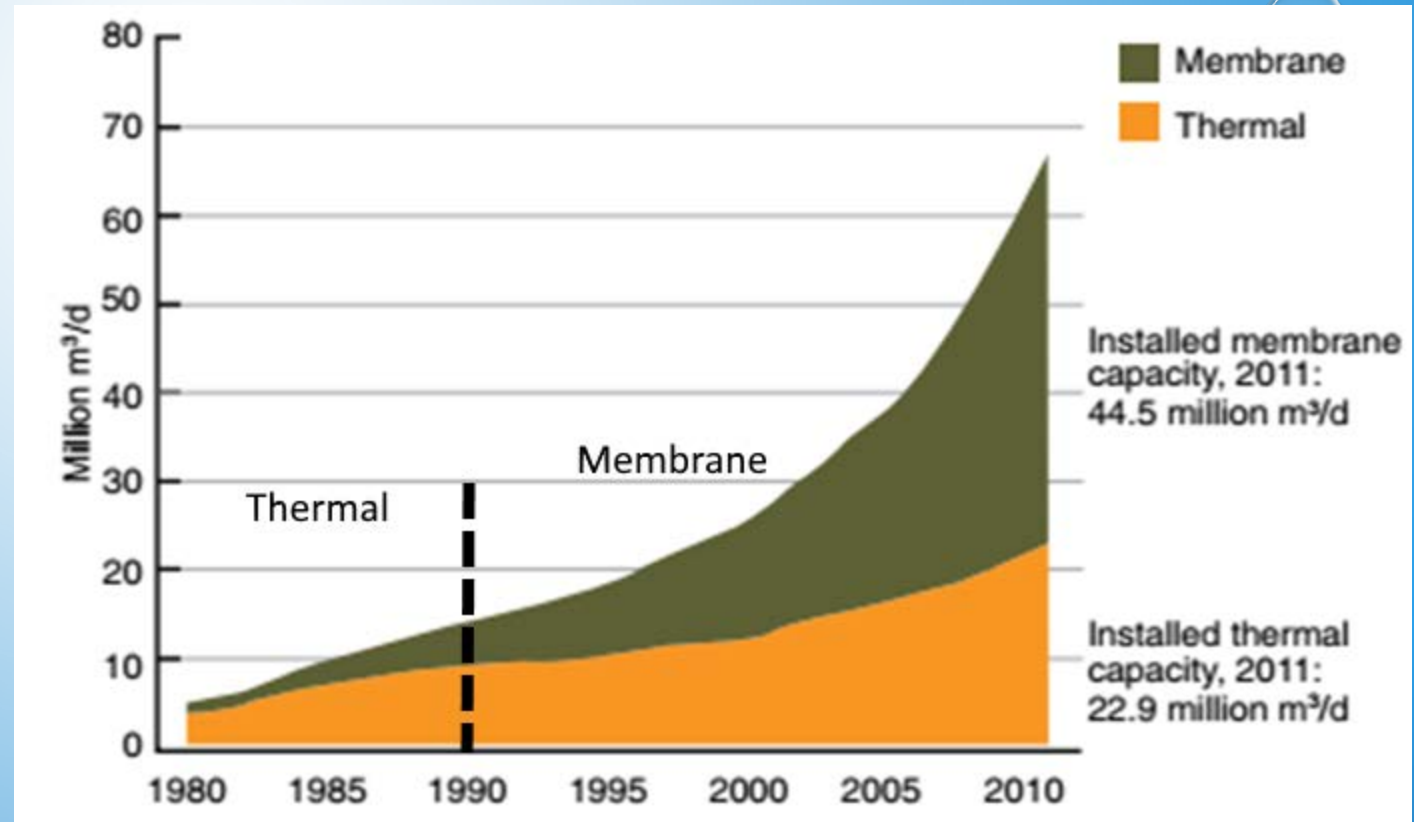
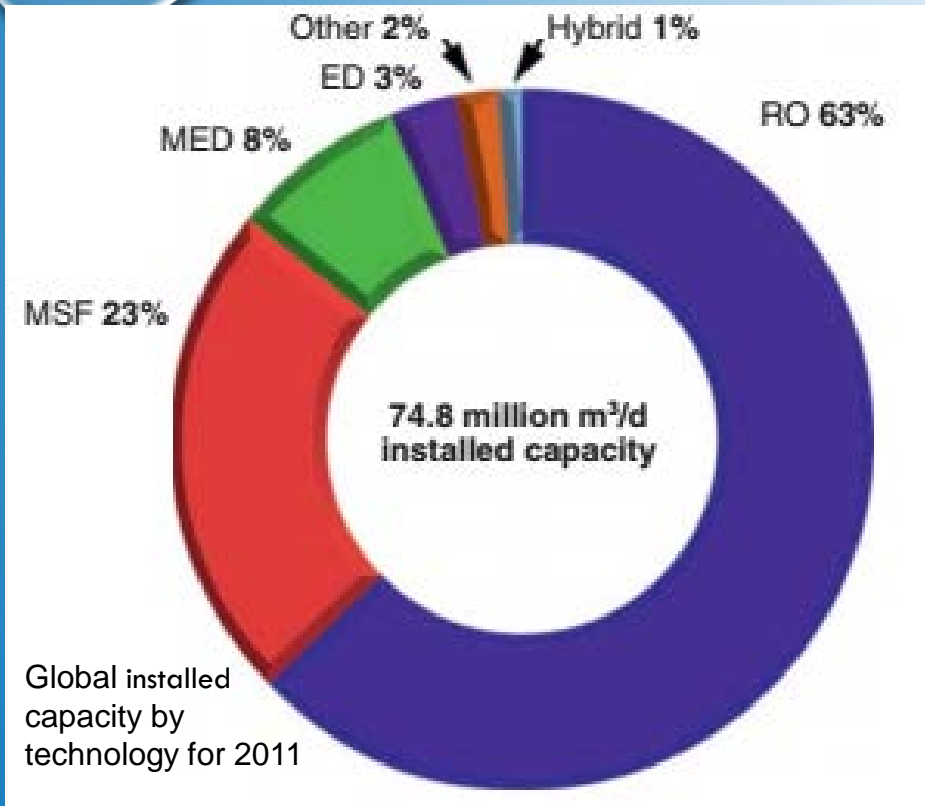
- Produce high purity water
- High water recovery (~ 97-99%)
- Robust

Disadvantages

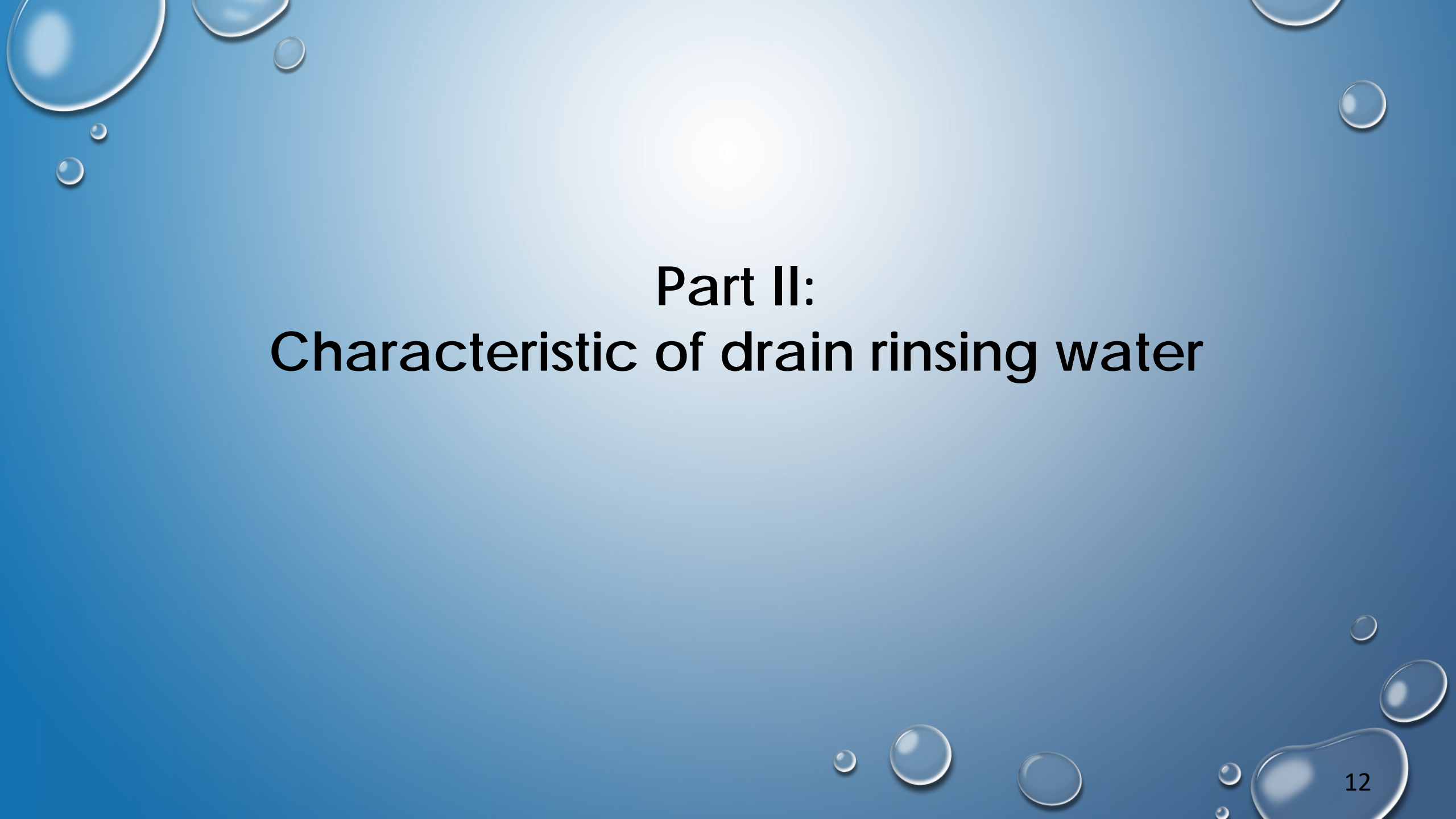
- Limited to relatively low-salinity water treatment applications
- It is cost prohibitive
- Use of chemicals for regeneration



Current Commercial Technologies



- Prior to 1990, membrane technologies made up less than 1/3 of the global water treatment capacity.
- Today, **membranes** account for just under **2/3 of the total installed treatment capacity**.
- Reverse Osmosis (RO) offers **smaller infrastructure**, and it is more **cost-effective** compared with traditional thermal processes.

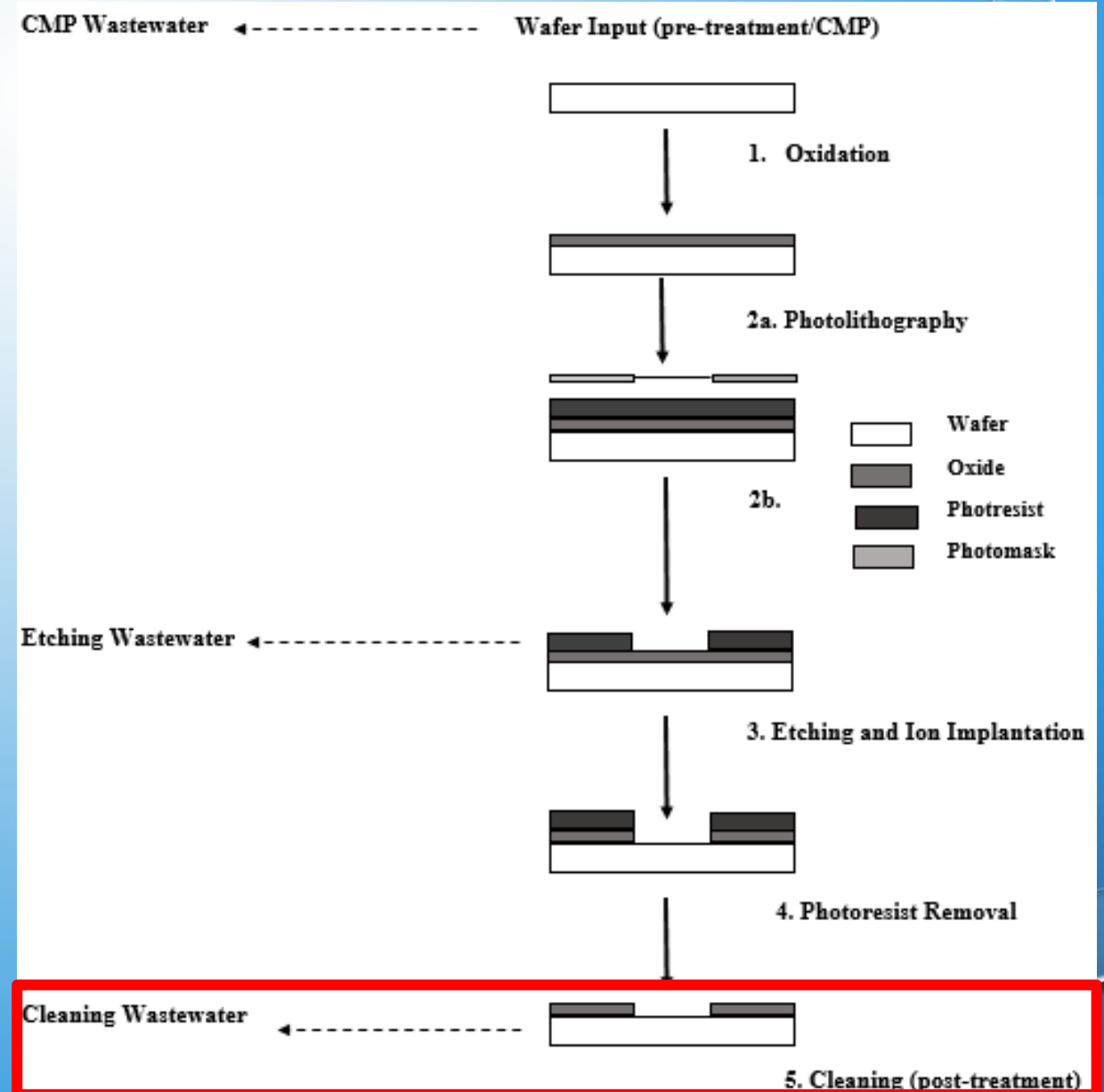


Part II:

Characteristic of drain rinsing water

Sampling of drain rinsing water

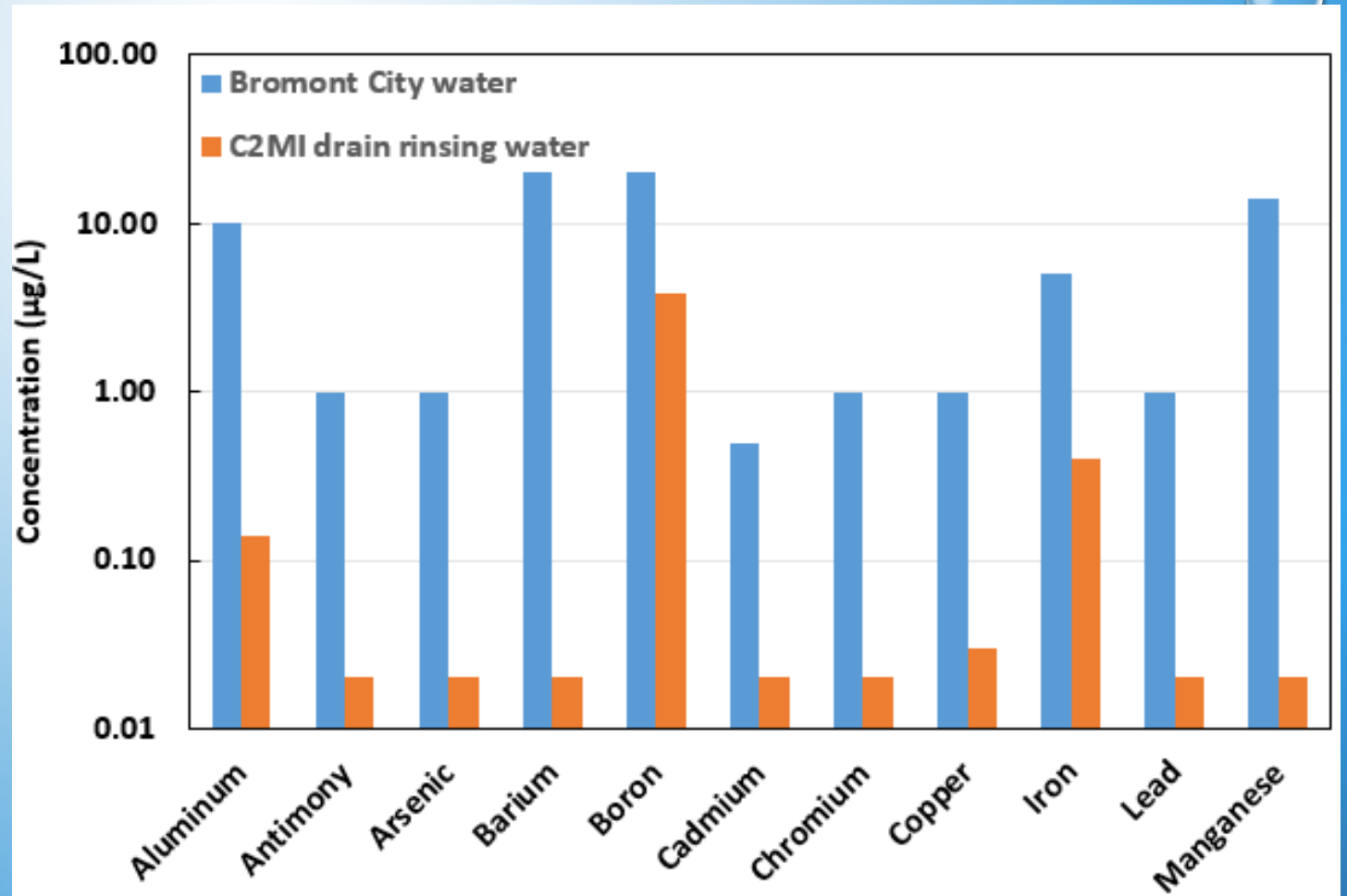
Preliminary and RCA clean	
Process and chemical ratio	Removal Goals
Preliminary cleaning; H ₂ SO ₄ /H ₂ O ₂ (4:1)	Organic carbon, Photoresist material
DI water (UPW: Ultra Pure Water)	Rinse
HF (0.5%)	Oxides
DI water (UPW)	Rinse
RCA	Particles, organics, some metals
Standard Clean 1 (SC1); NH ₄ OH/H ₂ O ₂ /H ₂ O (1:1:5) 70-90° C	
DI water (UPW)	Rinse
Standard Clean 2 (SC2); HCl/H ₂ O ₂ /H ₂ O (1:1:6) 70-90° C	Metals
DI water (UPW)	Rinse



Characteristic of drain rinsing water

Drain rinsing water -C2MI:

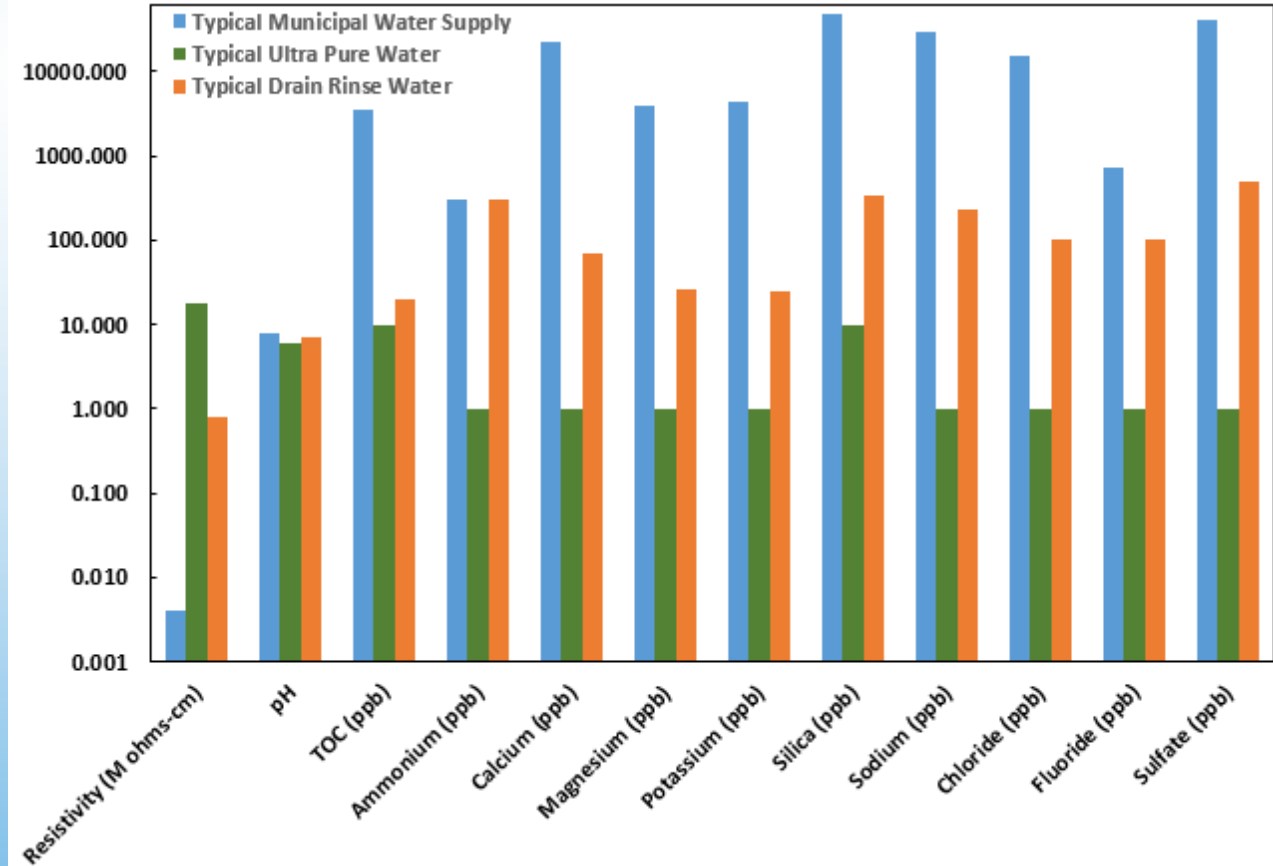
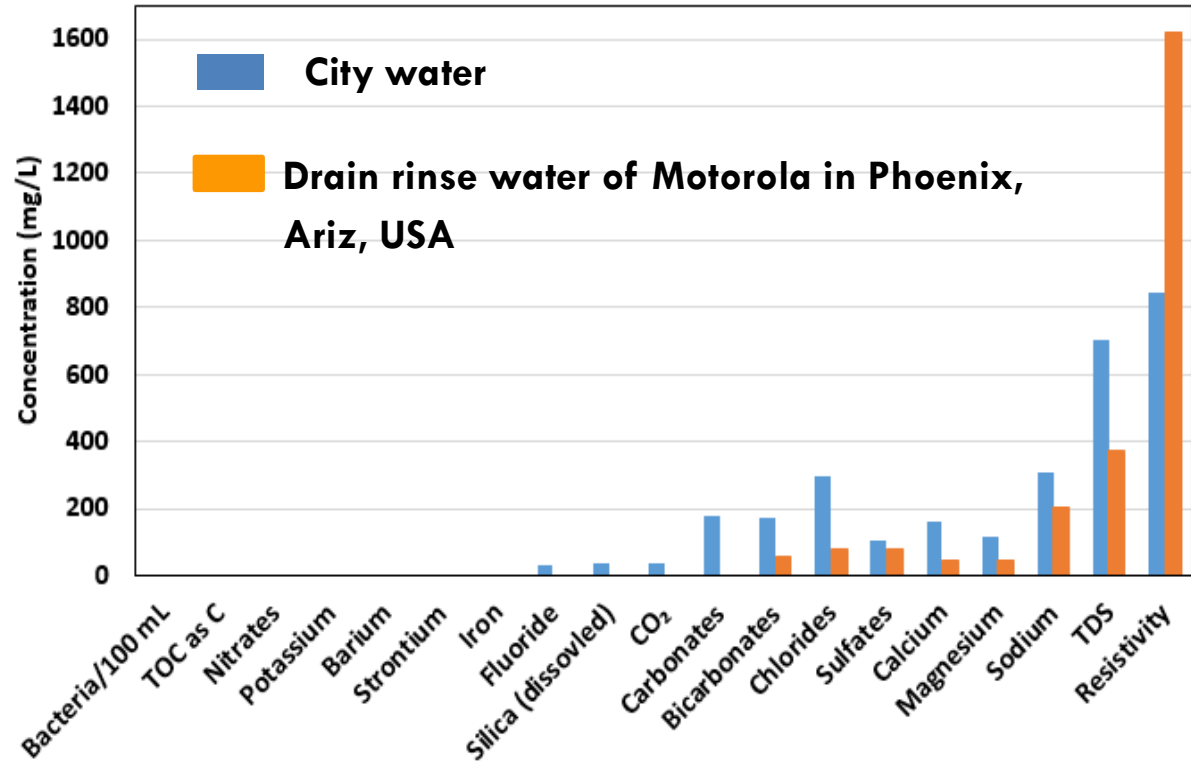
Water Quality Parameter	Rinsing water of C2MI
Turbidity (NTU)	0.07
pH	6-7
TOC (ppm)	0.1-0.9
COD (ppb)	0.03-0.12
Suspended solids > 0.45µm	0
Total Metal (ppb)	13.25
Sulphate (ppm)	<0.05
Fluoride (ppm)	<0.01
Chloride (ppm)	<0.05
Bromide (ppm)	<0.02
Nitrate (ppm)	<0.3
Phosphate (ppm)	<0.03



✓ **Drain rinse water contains small quantities of impurities**

Characteristic of drain rinsing water

Typical drain rinsing water quality comparison:



- ✓ Drain rinse water of all fabrication plants contains small quantities of impurities
- ✓ Less impurities than municipal water

Ref: DeGenova, J., "Recovery , reuse , and recycle of water in semiconductor wafer fabrication facilities," Environ. Prog., vol. 16, no. 4, 1997

Ref: R. Ajay and J. H. Ploeser, "Reusing rinse wastewater at a semiconductor plant," 1999

The background is a light blue gradient with several realistic water droplets of various sizes scattered across the top and bottom edges. The droplets have highlights and shadows, giving them a three-dimensional appearance.

Part III:

Semiconductor wastewater treatment technologies

Semiconductor wastewater treatment:

Conventional treatment solutions:

Waste type/treatment	Physicochemical	Evapoconcentration	Biochemical reactor	Filtration	Adsorption	Neutralization
Diluted waste (acid/base and rinse water)						***
Fluoride and phosphorous waste	***					*
Nitrogenous Waste		***	***			*
Colloids (from CMP processes)	***			**		*
Suspended particles (grinding and sawing processes)	***			**		*
Heavy metals	***					*
Diluted organic wastes	**				**	*

- **Neutralization:**

- ✓ Adjusting pH in acid and alkaline solutions

- **Physicochemical:**

- ✓ Typically based on the precipitation of metal hydroxides at variable pH.
- ✓ Including: pH adjustment; coagulation/flocculation; and filtration

- **Bio-treatment:**

- ✓ Based on growing bacteria

- **Evaporation:**

- ✓ Energy intensive but economic when valorization of the wastes is possible

Most effective on concentrated solutions

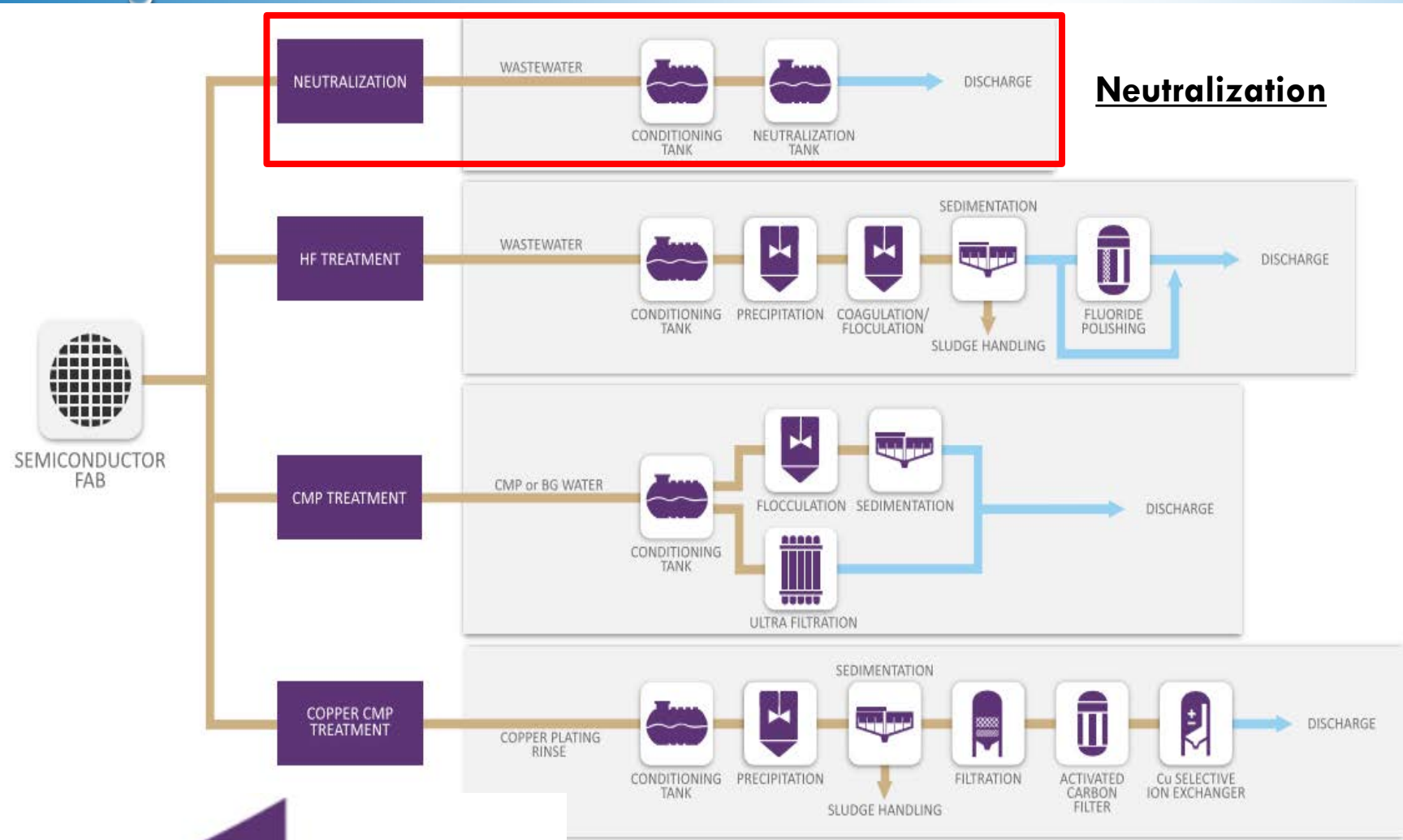
Ref: Chemistry in Microelectronics, 2013

Major wastewater streams in a semiconductor factory:

Rinsing water is discharged into environment or municipal sewers along with other wastes after neutralization

Semiconductor wastewater treatment:

Treatment solution for semiconductor wastewater via OVIVO:

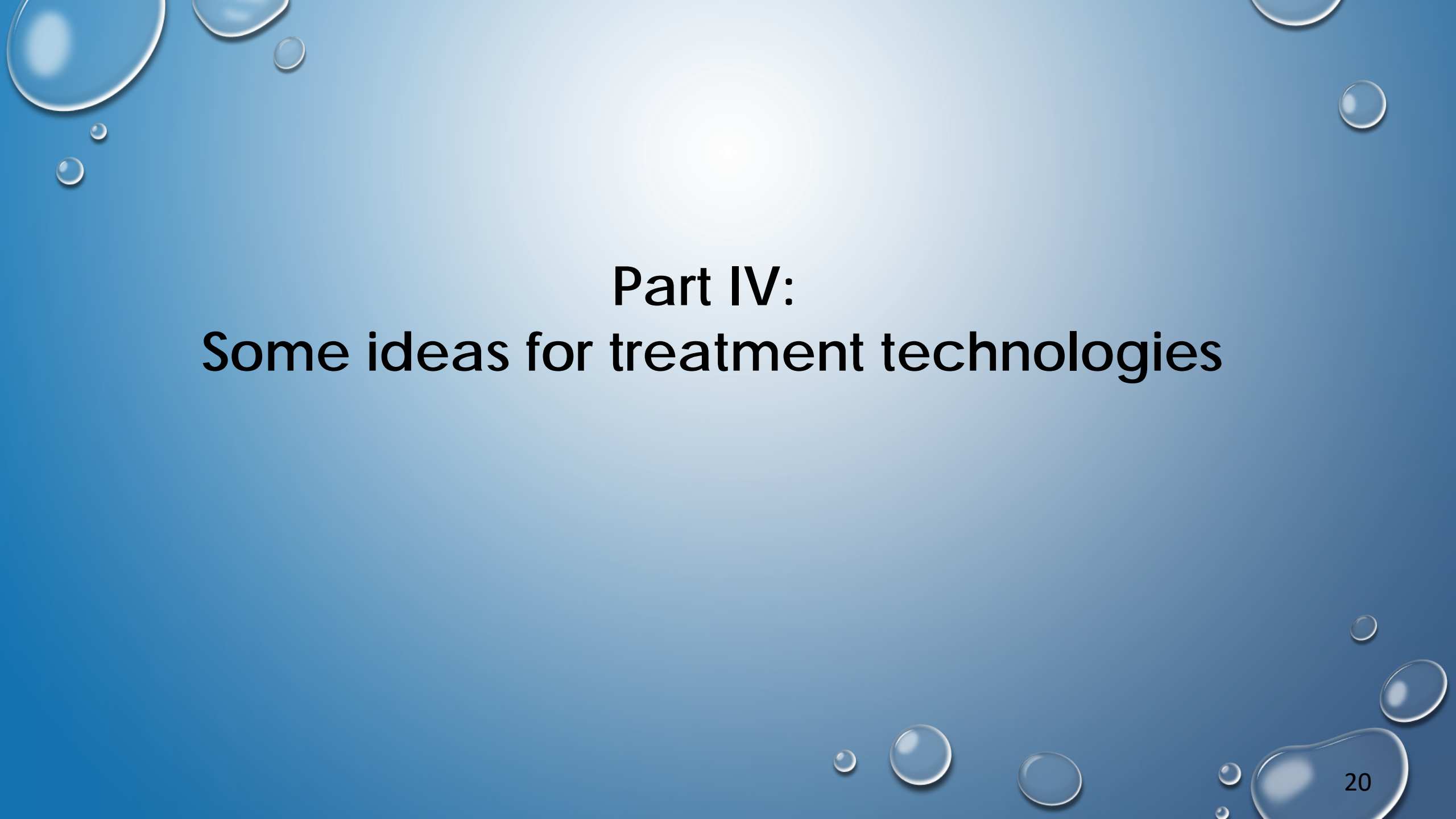


- ✓ The main focus on separating materials mostly from **CMP wastewater**
- ✓ Treatment to meet **environmental discharge; not reuse**
- ✓ **Drain rinse water** is discharged after neutralization process
- ✓ The research is limited to remove specific materials from **CMP wastewater**

Water recovery and reuse opportunities for drain rinsing water

Water separation from drain rinse water is economic:

- ✓ It decreases the total water usage from municipal water due to reuse application as Ultra Pure Water (UPW) in fabrication process
- ✓ It decreases the volume of the wastewater to be treated by a third party
- ✓ Possibility of valorization of the effluents
- ✓ Possibility of using renewable energies for treatment

The background is a light blue gradient with several realistic water droplets of various sizes scattered across the surface, primarily concentrated in the corners.

Part IV:

Some ideas for treatment technologies

Parameters for technology selection for drain rinsing water treatment:

- ✓ Able to produce UPW for reuse in fabrication process;
- ✓ Cost-effective;
- ✓ Robustness and low-maintenance;
- ✓ Easily scalable for treatment of large amount of drain rinse water;
- ✓ Minimum space requirement;
- ✓ Preferably use renewable energy.

Ideas for Treatment technology for semiconductor drain rinsing water treatment

Parameters Treatment method	Minimum space requirement	Robustness and low-maintenance	Use renewable energy	Easily scalable	Cost-effective	Produce UPW
Humidification-Dehumidification (HDH)	-	-	*	*	*	*
Forward osmosis (FO)	*	*	*	*	*	*
Freezing-Melting (FM)	-	-	*	*	*	*
Reverse Osmosis (RO)	*	-	-	*	-	*
Ion Exchange (IX)	*	-	-	-	-	*

- 1) Forward Osmosis
- 2) Freezing-Melting
- 3) Humidification-dehumidification
- 4) Reverse Osmosis
- 5) Ion Exchange



Thank you

Questions?

Open Discussion!